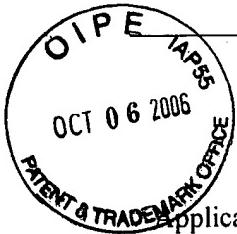


1752
October 4, 2006

Page 1 of 1

Please Direct All Correspondence to Customer Number 20995**TRANSMITTAL LETTER****INFORMATION DISCLOSURE STATEMENT**

Applicant : Ando et al.
 App. No : 10/572,709
 Filed : March 17, 2006
 For : POSITIVE RESIST COMPOSITION AND
 RESIST LAMINATE FOR LOW-
 ACCELERATION ELECTRON BEAM
 AND METHOD OF PATTERN
 FORMATION
 Examiner : Unassigned
 Art Unit : 1752

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

October 4, 2006

(Date)

 Neil S. Bartfeld, Ph.D., Reg. No. 39,901

Mail Stop Amendment
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application are:

- (X) An Information Disclosure Statement and PTO/SB/08 equivalent listing references for consideration:
- (X) Listing 8 references.
 - (X) Enclosing 7 references.
- (X) Return prepaid postcard.

The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment, to Account No. 11-1410.

 Neil S. Bartfeld, Ph.D.
 Registration No. 39,901
 Agent of Record
 Customer No. 20,995
 (619) 235-8550



INFORMATION DISCLOSURE STATEMENT

Applicant : Ando et al.
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 FORMATION
 Examiner : Unassigned
 Art Unit : 1752

Mail Stop Amendment
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing 8 references to be considered by the Examiner. Also enclosed are 7 foreign patent references and/or non-patent literature as listed on the Information Disclosure Statement.

This Information Disclosure Statement is being filed before the receipt of a first Office Action on the merits, and presumably no fee is required. If a first Office Action on the merits was mailed before the mailing date of this Statement, the Commissioner is authorized to charge the fee set forth in 37 C.F.R. § 1.17(p) to Deposit Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: October 4, 2006

By: 

Neil S. Bartfeld, Ph.D.
 Registration No. 39,901
 Agent of Record
 Customer No. 20,995
 (619) 235-8550



OCT 6 2006

PTO/SB/08 Equivalent

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(Multiple sheets used when necessary)

SHEET 1 OF 1

INFORMATION DISCLOSURE STATEMENT BY APPLICANT <small>(Multiple sheets used when necessary)</small>	Application No.	10/572,709
	Filing Date	March 17, 2006
	First Named Inventor	Tomoyuki Ando
	Art Unit	1752
SHEET 1 OF 1	Examiner	Unassigned
	Attorney Docket No.	SHIGA7.046APC

U.S. PATENT DOCUMENTS

U.S. PATENT DOCUMENTS				
Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant
	1	2003/113661 A1	10-05-2001	Sumitomo Chemical Co., Ltd.

FOREIGN PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS						
Examiner Initials	Cite No.	Foreign Patent Document Country Code-Number-Kind Code Example: JP 1234567 A1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	T ¹
	2	EP 0588 544 A2	03-23-1994	Urano et al.		
	3	JP 04-340553	11-26-1992	Tanaka Hatsuyuki et al.		Abstract Only
	4	JP 2002-341523	11-27-2002	Sasaki Tomoya et al.		Abstract Only
	5	JP 2002-373845	12-26-2002	Kagami Ichiro		Abstract Only
	6	JP 2003-177537	06-27-2003	Mizutani Kazuyoshi et al.		Abstract Only
	7	JP 2004-012513	01-15-2004	Endo Masataka et al.		Abstract Only

NON-PATENT LITERATURE DOCUMENTS

Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ¹
	8	Takao Utsumi. "Low-Energy E-Beam Proximity Lithography (LEEPL): Is the Simplest the Best?" <i>Jpn. J. Appl. Phys.</i> 38(Part 1, No. 12B):7046-7051 (1999).	

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***Examiner:** Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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T¹ - Place a check mark in this area when an English language Translation is attached